

### IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:	)	
•	:	Examiner: L. Scott, Jr.
Naoto SANO, et al.	)	
	:	Group Art Unit: 2828
Application No.: 09/163,402	)	
	:	
Filed: September 30, 1998	)	
	:	
For: GAS LASER DEVICE AND EXPOSURE	)	
APPARATUS USING THE SAME	:	October 6, 2004

# Mail Stop RCE

00684.002745

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Transmitted herewith is a Request for Continued Examination (RCE) and a Preliminary Amendment in the above-identified application.

X No additional fee is required.

The fee has been calculated as shown below:

			CLAIMS AS AMI	ENDED			·
	CLAIMS REMAINING AFTER AMENDMENT		HIGHEST NO. PREVIOUSLY PAID FOR	PRE	SENT EXTRA	RATE	ADDITIONAL FEE
TOTAL CLAIMS	55	MINUS	72	=	0	x \$9 \$18	\$ 0.00
INDEP. CLAIMS	9	MINUS	15	=	0	x \$43 \$88	\$ 0.00
Fee for Multip	le Dependent claims \$15	0°/\$300					
•			TOTAL ADDITION FOR THIS AMEND				\$ 0.00

	°Verified Statement claiming small entity status is enclosed, if not filed previously.
	A check in the amount of \$ is enclosed.
	Charge \$ to Deposit Account No. 06-1205. A duplicate of this sheet is enclosed.
X	Any prior general authorization to charge an issue fee under 37 CFR 1.18 to Deposit Account No. 06-1205 is hereby revoked. The Commissioner is hereby authorized to charge any additional fees under 37 CFR 1.16 and 1.17 which may be required during the entire pendency of this application, or to credit any overpayment, to Deposit Account No. 06-1205. A duplicate of this paper is enclosed.
	A check in the amount of \$ to cover the fee for a month extension is enclosed.
	A check in the amount of \$ to cover the Information Disclosure Statement fee is enclosed.
X	Applicants' attorney, Steven E. Warner, may be reached in our Washington, D.C. office by telephone at (202) 530-1010. All correspondence should be directed to our address given below.
	Respectfully submitted,
	Attorney for Applicants Jack S. Cubert

FITZPATRICK, CELLA, HARPER & SCINTO

30 Rockefeller Plaza

New York, New York 10112-3800

Facsimile: (212) 218-2200

SEW/JSC/dc

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Registration No. 24,245

## **PATENT APPLICATION**

# OCT 0 6 2004

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EXPOSURE APPARATUS USING	)	
THE SAME		October 6, 2004

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## **PRELIMINARY AMENDMENT**

Sir:

The Examiner is respectfully requested to amend the above-identified application as follows.